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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

TAKAHASHI et al Atty. Ref.: 829-585; Confirmation No.

Appl. No. 09/936,818 TC/A.U. 1765

Filed: September 18, 2001 Examiner: Song

For: CRYSTAL GROWTH METHOD, PRODUCTION METHOD OF SEMICONDUCTOR
MICROSTRUCTURE, SEMICONDUCTOR DEVICE AND SYSTEM

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February 25, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

Responsive to the Official Action dated October 27, 2004 (for which petition is hereby made for a one month extension of time), please amend the above-identified application as follows:

Entered
W/RCE
dtn
4/22/05
KA
4/28/05